

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

In re Application of MAJIMA et al.

Application No. 09/890,550

Examiner: VO, Hai

Filed: January 14, 2002

Group Art Unit: 1771

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OCT 28 2005

For: POROUS SILICON CARBIDE SINTER AND SILICON CARBIDE-METAL
COMPOSITE THAT ARE OPTIMAL FOR A WAFER GRINDER TABLE

AMENDMENT

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being transmitted
transmitted to the USPTO or deposited with the United States
Postal Service with sufficient postage as first class mail in an
envelope addressed to Commissioner for Patents, Alexandria,
VA 22313-1450 on 10/28/05.

Sarah E. Smith

Reg. No. 50488

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

This is in response to the Final Office Action dated July 28, 2005. Please amend the
above-identified application as follows:

Amendments to the claims begin on page 2 of this paper.

Remarks/arguments begin on page 5 of this paper.

OK to enter,
HV 11/09/05

{WP264877;1}